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Application/Control No.	Applicant(s)/Patent under Reexamination	_
10/779,712	FUJITA ET AL.	
Examiner	Art Unit	_
Wen-Ying P. Chen	2871	

	SEARCHED		
Class	Subclass	Date	Examiner
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INT	INTERFERENCE SEARCHED		
Class	Subclass	Date	Examiner
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SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
Citations search of tagged references	12/13/2005	WPC
349/155-157 combined with key word search of all databases in EAST	12/14/2005	WPC
Reviewed previously cited references	12/14/2005	WPC
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